



The multipurpose KR1114EU4 chip, which controls pulsed sources of secondary power supply circuit, is also connected in the control circuit. It operates when the input voltage changes from 7 to 40 V, allows us to regulate the commutation frequency up to 200 kHz, and provides the output current up to 200 mA. When external condenser is connected, a regime of "smooth switching" can be provided. In this case, the voltage on output terminals increases smoothly when the source is switched on. Frequency may be tuned within 50% of the cycle duration with the help of external resistor.

A feedback signal is fed into the KR1114EU4 input (the amplifier of mismatch signal). As it increases, the duration of the "on" mode of the power transistor is reduced, and hence the output voltage is stabilized. Analogously, the thyatron heating current can be stabilized when a current feedback signal is picked.

The unit was used for stabilization of heating voltage on the TGI1-2500/50 hydrogen thyatron generator of a copper vapor laser. With no change, it also can be used for heating supply of the TGI1-1000/50 hydrogen thyatron generator. Using the circuit design described above and higher-power elements, one can develop stabilized heating supply voltage on cathodes in hydrogen thyratrons where currents reach several tens of amperes.

In Fig. 2, the dependence of output voltage on the supply voltage is shown. It is seen from this figure that voltage on the load deviates by 0.1 V from its rated value when the input voltage varies from 195 to 250 V. Thus, the unit provides stability of output voltage within 1.5% of its rated value. In most cases, it is sufficient.

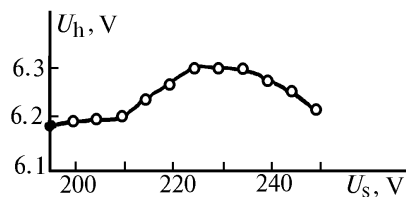


FIG. 2. Dependence of heating voltage  $U_h$  on the TGI1 2500/50 hydrogen thyatron generator on the supply voltage  $U_s$ .

The unit differs from previously known ones by:

a) absence of power transformer operating at a frequency of 50 Hz and having large overall dimensions and mass;

b) high degree of output voltage stabilization with minimum possible number of circuit elements;

c) absence of auxiliary transformer to supply the unit itself.

#### REFERENCES

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